

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
 Tadahihiro OHMI et al.) Group:
 Serial No.:)
 Filed: July 13, 2001) Examiner:
 Title: METAL MATERIAL HAVING FORMED THEREON)
 CHROMIUM OXIDE PASSIVE FILM AND METHOD))
 FOR PRODUCING THE SAME, AND PARTS))
 CONTACTING WITH FLUID AND SYSTEM FOR))
 SUPPLYING FLUID AND EXHAUSTING GAS))

PRELIMINARY AMENDMENT

Hon. Commissioner of Patents and Trademarks
 Washington, D.C. 20231

Sir:

Applicant hereby submits the following Amendment.

IN THE CLAIMS

1. (Amended) Metallic material provided with a chromium-oxide passivation film comprising a passivation film consisting of chromium oxide obtained by oxidizing a chromium coat on the metallic material of which surface roughness (Ra) is not more than [1.5im] 1.5 μ m.

2. (Amended) The metallic material provided with the chromium-oxide passivation film according to claim 1, said film having pin holes wherein pin holes of said chromium-oxide passivation film are filled.

3. (Amended) A method for manufacturing metallic material on which a chromium-oxide passivation film is formed, comprising the step of: